

	Application No.	Applicant(s)
Notice of Allowability		
	10/661,547 Examiner	JOSHI, POORAN C. Art Unit
	ZXXIIIIIOI	Artonic
	Toniae M. Thomas	2822
The MAILING DATE of this communication appearance All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in to other appropriate communication is sulfilled. This application is sulfilled.	his application. If not included ication will be mailed in due course. THIS
1. This communication is responsive to the amendment filed	<u>on 09 February 2005</u> .	
2. The allowed claim(s) is/are 7 and 17-23.		
3. $\boxtimes$ The drawings filed on <u>19 January 2005</u> are accepted by th	e Examiner.	
<ul> <li>4. ☐ Acknowledgment is made of a claim for foreign priority unall All b) ☐ Some* c) ☐ None of the:</li> <li>1. ☐ Certified copies of the priority documents have</li> <li>2. ☐ Certified copies of the priority documents have</li> <li>3. ☐ Copies of the certified copies of the priority documents have a longer than the l</li></ul>	e been received. e been received in Application	No
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a IENT of this application.	reply complying with the requirements
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give	itted. Note the attached EXAMes reason(s) why the oath or d	MINER'S AMENDMENT or NOTICE OF lectaration is deficient.
6. CORRECTED DRAWINGS ( as "replacement sheets") mus  (a) including changes required by the Notice of Draftspers  1) hereto or 2) to Paper No./Mail Date  (b) including changes required by the attached Examiner's Paper No./Mail Date  Identifying Indicia such as the application number (see 37 CFR 1.	son's Patent Drawing Review ( . s Amendment / Comment or in .84(c)) should be written on the	the Office action of
each sheet. Replacement sheet(s) should be labeled as such in the	he header according to 37 CFR	1.121(d).
<ol> <li>DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT</li> </ol>	sit of BIOLOGICAL MATEF FOR THE DEPOSIT OF BIOL	RIAL must be submitted. Note the OGICAL MATERIAL.
Attachment(s)  1. ☐ Notice of References Cited (PTO-892)  2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)  3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0	6. 🔲 Interview Sum	rmal Patent Application (PTO-152) nmary (PTO-413), ail Date nendment/Comment
Paper No./Mail Date  4. Examiner's Comment Regarding Requirement for Deposit	8. 🛛 Examiner's St	atement of Reasons for Allowance
of Biological Material	9.  Other	
	· Particular	Mary Wilczewski Primary Examiner

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## Reasons for Allowance

The following is an examiner's statement of reasons for allowance: the prior art of record fails to anticipate, teach or suggest a method for fabricating composite thin films substantially as claimed. As stated in the previous Office action mailed on 21 September 2001, Tomita (US 5,468,514) discloses a method for fabricating composite thin films (see fig. 1 and col. 2, line 64 - col. 3, line 3). As discussed in the previous action, Tomita discloses the steps of: after depositing a chemical precursor solution onto a suitable substrate and forming a wet thin film of Ta<sub>2</sub>O<sub>5</sub>, baking the Ta<sub>2</sub>O<sub>5</sub> thin film and removing organics present; forming a continuous Ta<sub>2</sub>O<sub>5</sub> thin film on the substrate, and baking the continuous Ta<sub>2</sub>O<sub>5</sub> thin film. However, Tomita does not anticipate, teach or suggest the following limitation of: drying the thin film subsequent to depositing a chemical precursor solution onto the substrate and forming a wet thin film of Ta<sub>2</sub>O<sub>5</sub>, and prior to baking the Ta<sub>2</sub>O<sub>5</sub> thin film and removing organics present. There is no teaching or suggestion within the prior art of record to modify Tomita by drying the thin film subsequent to depositing a chemical precursor solution onto the substrate and forming a wet thin film of Ta<sub>2</sub>O<sub>5</sub>, and prior to baking the Ta<sub>2</sub>O<sub>5</sub> thin film and removing organics present.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Toniae M. Thomas whose telephone number is (571) 272-1846. The examiner can normally be reached on Monday-Thursday from 8:30 a.m. to 5:30 p.m..

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Amir Zarabian can be reached on (571) 272-1852. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

TMT 19 February 2005

> Mary Wilczewski Primary Examiner